

Business Model and Capital Allocation Strategy

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Business Model and Capital Allocation Strategy

Key messages

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Our investments have created significant shareholder value...

 We have invested substantially into technology leadership and have thereby created significant shareholder value

... our growth continues well into the next decade...

 Our products and services will continue to enable our customers to achieve cost effective shrink, which will continue to fuel a highly profitable industry in innovation and expansion

... creating significant financial opportunity ...

 Based on different market scenarios we have an opportunity to grow our annual revenue for 2025: between 15B€ (low market) – 24B€ (high market)

... which continues to deliver strong shareholder value

 We expect to continue to return significant amounts of cash to our shareholders through a combination of share buybacks and growing dividends

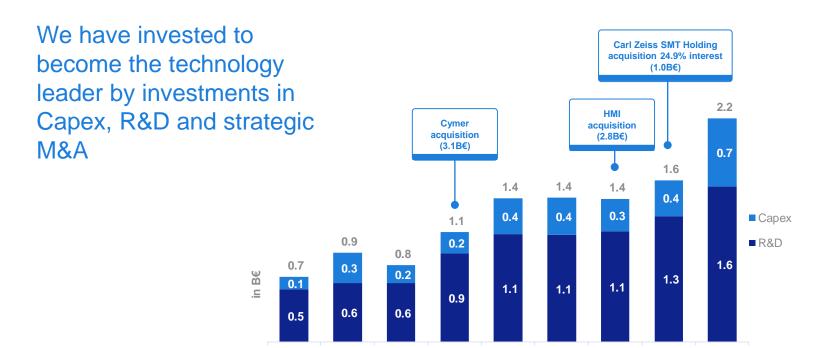


Historical Shareholder value creation

ASML is the technology leader enabling shrink with resulting cost reduction for our customers



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2012

2013

2014

2015

2017*

2016

2018**

2010

2011

^{*} ASML contribution Zeiss SMT capex included as of 2017

^{** 2018} capex and R&D consists of YTD Q3 actuals and Q4 estimate

ASML total revenues grew at a CAGR of 12% since 2010

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- Systems revenue grew at a 10% CAGR since 2010
- Installed base management
 - 20% CAGR since 2010 driven by holistic lithography, upgrades and growing installed base
 - Now approximately one quarter of our total revenue
- Gross Margin trend reflecting the strength of our DUV and Applications business and progress in EUV profitability



ASML created significant shareholder value over the past 8 years....

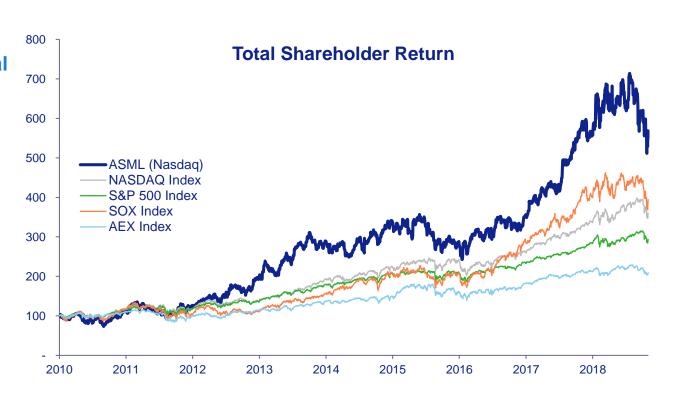
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ASML (Nasdaq) Total Shareholder Return CAGR 22% versus NASDAQ at 16%



Source: Bloomberg (Total Shareholder Return: index = 2010)



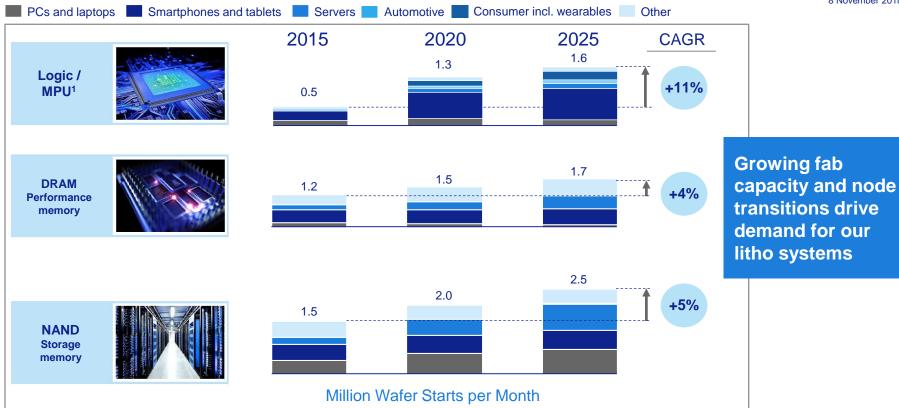
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Continuing growth

Expected content and unit growth of semiconductor end markets translates into growth of wafer demand in all segments



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¹ Advanced Logic and MPU nodes only ≤ 32 nm Source: Gartner device units 2017-2022; ASML model extrapolated through 2025

Lithography spend increasing on future nodes



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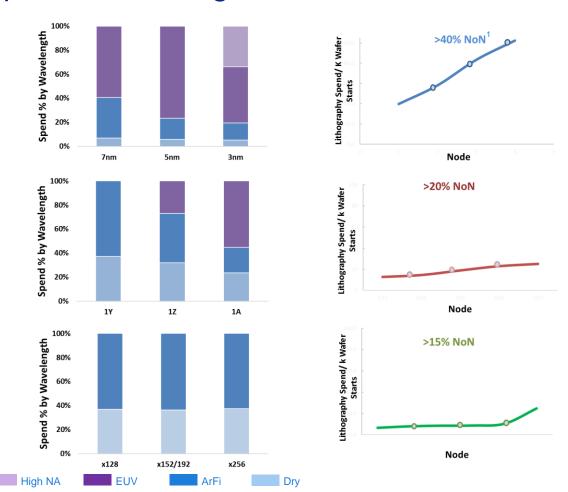
DRAM Performance memory

100K wafers/month

NAND Storage memory

120K wafers/month

¹ NoN: Node on Node



Model assumptions based on latest insights (2020)



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Logic / MPU

Performance Memory

Storage Memory

Market share assumptions: EUV 100%, ArFi 90%, Dry 60%

Genera

- **EUV** insertion 2019
- 3 year cadence

EUV insertion 2020

- EUV in storage class memory after 2025
- 3D NAND: stack of stacks

Market (Low/High)

- Reference 16/14nm, 270 kwspm¹
- Node on node (reduction):

Low: -20% 0% High:

Bit growth:

Low: 15% High: 25% • Bit growth:

Low: 35% High: 45%

EUV Insertion (Low/High)

- EUV initial layer range: Low: 5-7 for smaller 'test' node High: 10-14 for larger HVM² nodes
- EUV initial layer range:

Low: High:

Growing at subsequent nodes

¹ kwspm: 1000 wafer starts per month - ² HVM: High Volume Manufacturing

Our updated model supports revenue in a moderate market scenario of ~13 B€ in 2020



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ASML modeled Sales in 2020

(in **B€**)

Market demand

based on mid EUV insertion

	Worldwide units	Sales	
High demand	EUV 35 ArFi 90 Dry 220	Systems Installed Base Management	11.0 3.7
	Total 345	Total	14.7

	Worldwide units			Sales
Low demand	EUV ArFi Dry	20 44 14)	Systems Services (peops)	6.5 3.6
	Total	204	Total	10.1

EUV insertion

based on moderate market

Total

Total

Worldwi	de units		Sales			
EUV ArFi Dry	33 60 180	Systems Installed Base Management	9.2 3.7	High		
Total	273	Total	12.9	insertion		
Worldwi	de units		Sales			
EUV ArFi Dry	20 75 110	Svetems Silviny	8.2 3.6	Low insertion		

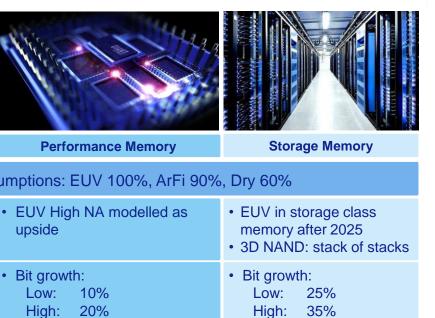
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Model assumptions 2025



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General	EUV High NA high volume from 20243 year cadence
Market (Low/High)	 Reference 16/14nm, 270 kwspm¹ Node on node (reduction): Low: -20% High: 0%
EUV Insertion (Low/High)	 20-30 EUV exposures First EUV High NA node ~ 5-10 exposures

 80-90% of wafer capacity converted to nodes with 1-5 exposures of EUV

upside

¹ kwspm: 1000 wafer starts per month

Our simulation model supports revenue between 15 B€ (Low Market) – 24 B€ (High Market)

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ASML modeled Sales in 2025

(in B€)

Market demand

based on mid EUV insertion

EUV insertion

based on moderate market

	Worldwide units		Sales
High demand	High NA 9 EUV 55 ArFi 60 Dry 200	Systems Installed Base management	17.9 6.4
	Total 324	Total	24.3

...

Worldwide	units		Sales	
High NA EUV ArFi Dry	7 43 40 150	Systems Installed Base management	13.4 5.9	
Total	240	Total	19.3	

High insertion

	Worldwide units		Sales
Low demand	High NA 5 EUV 32 ArFi 35 Dry 140	Systems Installed Base management	10.2 4.8
	Total 212	Total	15.0

Worldwide	units		Sales	
High NA EUV ArFi Dry	3 45 40 150	Systems Installed Base management	12.7 5.8	Low
Total	238	Total	18.5	

Low insertion

ASML updated Financial Model

	2017 (Actual)	2018 (Guidance)	2020 (CMD 2016)	2020 (Scenario) (Moderate market)	2025 (Scenarios)
Total Sales	9.1B€	~11B€	~11B€	~13B€	~15 - 24B€
Gross margin %	45.0%	~47%	>50%	>50%	>>50%
R&D % sales	14%	~14%	~13%	~14%	~13%
SG&A % sales	5%	~5%	~4%	~4%	~4%
Capex % sales	4%	~6%	~4%	~4%	~3%
Cash Conversion Cycle	224 days	~210 days	<200 days	<200 days	<200 days
Effective Tax Rate	13%	~14%	~14%	~14%	~14%

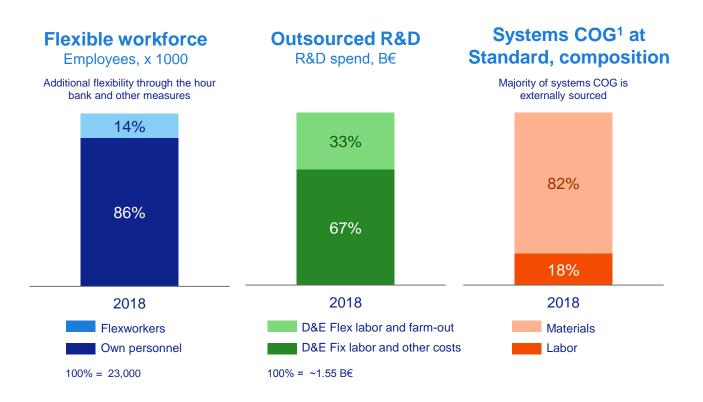
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Our flexible operating model can deal with the industry volatility and uncertainties



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¹ COG: Cost of Goods

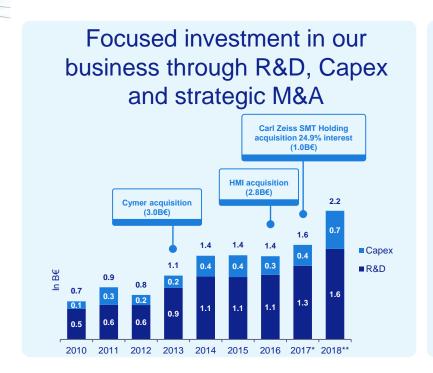


Continued shareholder value creation..

ASML's capital allocation policy

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Maintain a strong and flexible balance sheet

^{*} ASML contribution for Zeiss SMT capex included as of 2018

^{** 2018} estimate for capex and R&D consists of year to date Q3 actuals and Q4 guidance

Business Model and Capital Allocation Strategy Summary



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Forward Looking Statements

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This document contains statements relating to certain projections, business trends and other matters that are forward-looking, including statements with respect to expected trends and outlook, strategy, bookings, expected financial results and trends, including expected sales, EUV revenue, gross margin, capital expenditures, R&D and SG&A expenses, cash conversion cycle, and target effective annualized tax rate, and expected financial results and trends for the rest of 2018 and 2019, expected revenue growth and demand for ASML's products in logic and memory, expected annual revenue opportunity in 2020 and for 2025 and expected EPS potential in 2020 with significant growth in 2025, expected trends in the lithography system market, fab capacity by segment. the automotive and artificial intelligence industries, connectivity, semiconductor end markets and new semiconductor nodes, expected acceleration of chipmakers' performance for the next decade, expected EUV insertion and transistor density growth, trends in DUV systems revenue and Holistic Lithography and installed based management revenues, statements with respect to expectations regarding future DUV sales, including composition, margins, improvement of operations and performance. DUV product roadmaps, expected benefits of the holistic productivity approach, including in terms of wafers per year, expected industry trends and expected trends in the business environment, statements with respect to customer demand and the commitment of customers to High NA machines and to insert EUV into volume manufacturing by ordering systems, expected future operation of the High NA joint lab, statements with respect to holistic lithography roadmaps and roadmap acceleration, including the introduction of higher productivity systems in 2019 (including the expected shipment of NXE:3400C and expected timing thereof) and the expected benefits, ASML's commitment to volume manufacturing and related expected plans until 2030, ASML's commitment to secure system performance, shipments, and support for volume manufacturing, including availability, timing of and progress supporting EUV ramp and improving consistency, productivity, throughput, and production and service capability enabling required volume as planned, including expected shipments, statements with respect to growth of fab capacity driving demand in lithography systems, planned customer fabs for 200 systems and expected first output in 2019, expected EUV value increase and increase in EUV margins and ASML's expectation of EUV profitability at the DUV level, expected installed base of EUV systems, expected customer buildout of capacity for EUV systems. EUV estimated demand by market, expected increase in lithography intensity, statements with respect to the expected benefits of EUV, including year-on-year cost reduction and system performance, and of the introduction of the new DUV system and expected demand for such system, the expected benefits of HMI's e-beam metrology capabilities, including the expansion of ASML's integrated Holistic Lithography solutions through the introduction of a new class of pattern fidelity control, the extension of EUV to enable cost effective single patterning shrink with EUV, statements with respect to ASML's applications business, including statements with respect to expected results in 2018, expected growth of the applications business and expected drivers of growth, expected growth in margins, continued shrink and drivers, and expected accuracy, defect control and performance improvements, shrink being a key driver supporting innovation and providing long-term industry growth. Jithography enabling affordable shrink and delivering value to customers. DUV. Holistic Lithography and EUV providing unique value drivers for ASML and its customers, expected industry innovation, the expected continuation of Moore's law and that EUV will continue to enable Moore's law and drive long term value for ASML beyond the next decade, intention to return excess cash to shareholders through stable or growing dividends and regularly timed share buybacks in line with ASML's policy, statements with respect to the expectation to continue to return cash to shareholders through dividends and share buybacks, and statements with respect to the expected impact of accounting standards. You can generally identify these statements by the use of words like "may", "will", "could", "should", "project", "believe", "anticipate", "expect", "plan", "estimate", "forecast", "potential", "intend", "continue", "targets", "commits to secure" and variations of these words or comparable words. These statements are not historical facts, but rather are based on current expectations, estimates, assumptions and projections about the business and our future financial results and readers should not place undue reliance on them.

Forward-looking statements do not guarantee future performance and involve risks and uncertainties. These risks and uncertainties include, without limitation, economic conditions, product demand and semiconductor equipment industry capacity, worldwide demand and manufacturing capacity utilization for semiconductors, including the impact of general economic conditions on consumer confidence and demand for our customers' products, competitive products and pricing, the impact of any manufacturing efficiencies and capacity constraints, performance of our systems, the continuing success of technology advances and the related pace of new product development and customer acceptance of and demand for new products including EUV and DUV, the number and timing of EUV and DUV systems shipped and recognized in revenue, timing of EUV orders and the risk of order cancellation or push out, EUV production capacity, delays in EUV systems production and development and volume production by customers, including meeting development requirements for volume production, demand for EUV systems being sufficient to result in utilization of EUV facilities in which ASML has made significant investments, potential inability to successfully integrate acquired businesses to create value for our customers, our ability to enforce patents and protect intellectual property rights, the outcome of intellectual property litigation, availability of raw materials, critical manufacturing equipment and qualified employees, trade environment, changes in exchange rates, changes in tax rates, available cash and liquidity, our ability to refinance our indebtedness, distributable reserves for dividend payments and share repurchases, results of the share repurchase plan and other risks indicated in the risk factors included in ASML's Annual Report on Form 20-F and other filings with the US Securities and Exchange Commission. These forward-looking statements are made only as of the date of this document. We do not undertake to update or revise the forward-look

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